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Machine Learning and Compressed Sensing in Image Reconstruction

Guest Editors:

Message from the Guest Editors

Prof. Dr. Markus Haltmeier Department of Mathematics, University of Innsbruck, Innsbruck, Austria

Prof. Dr. Linh. V. Nguyen

Department of Mathematics, University of Idaho, Moscow, ID, USA

Deadline for manuscript submissions: closed (30 September 2019)



Dear Colleagues,

The development of fast and accurate reconstruction algorithms plays a central role in modern imaging systems. Examples include x-ray tomography, ultrasound imaging, photoacoustic imaging, super-resolution imaging, and magnetic resonance imaging. Compressed sensing and machine learning are successful tools for various imaging applications. In compressed sensing, iterative algorithms based on prior information have been applied for image reconstruction. Such algorithms can be time-consuming as the forward and adjoint problems have to be computed repeatedly. Recently, a new class of algorithms based on machine learning. especially deep learning. for compressed sensing and other image reconstruction tasks appeared. With deep learning, image reconstruction can be performed efficiently using artificial neural networks, whose weights are based on training data. This Special Issue focuses on the latest research and development of compressed sensing and machine learning for image reconstruction

Prof. Dr. Markus Haltmeier Prof. Dr. Linh. V. Nguyen *Guest Editors*







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Editor-in-Chief

Message from the Editor-in-Chief

Prof. Dr. Giulio Nicola Cerullo Dipartimento di Fisica, Politecnico di Milano, Piazza L. da Vinci 32, 20133 Milano, Italy As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal Applied Sciences has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multi-dimensional network.

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